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| 945500                            |                               |        |     | Application Number     | 10/644,958      |  |
| INF                               | ORMATION D                    | ISCLOS | URE | Filing Date            | 08/21/2003      |  |
|                                   | ATEMENT BY                    |        |     | First Named Inventor   | NORIAKI FUKIAGE |  |
| 317                               | AILMENT DI                    |        |     | Art Unit               | 1762            |  |
| (Use as many sheets as necessary) |                               |        |     | Examiner Name          |                 |  |
| Sheet                             | 1                             | of     | 1   | Attorney Docket Number | 071469-0304673  |  |

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| Examiner<br>Signature | /Kelly Stouffer/ | ** | Date<br>Considered | 02/06/2007 |
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Complete if Known Substitute for form 1449B/PTO Application Number 10/644,958 INFORMATION DISCLOSURE Filing Date 08/21/2003 STATEMENT BY APPLICANT First Named Inventor **NORIAKI FUKIAGE** Art Unit 1762 (Use as many sheets as necessary) Examiner Name Attorney Docket Number 071469-0304673

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| Examiner<br>Signature | /Kelly Stouffer/ | j | Date<br>Considered | 02/06/2007 |

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